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(54) [Name of the Invention]

Electret

Detailed explanation of the Invention

The present invention is an invention about an electret. In more details, the present invention is an invention about an electret.

- (1) which is formed as a film shaped or sheet shaped material, which is formed from copolymer material obtained from acrylic acid, methacrylic acid or maleic acid and ethylene or styrene, is used, and its two surfaces carry charges with a different sign,
- (2) which is formed as a film shaped or sheet shaped material, which is formed from copolymer material obtained from the metal salt of acrylic acid, methacrylic acid or maleic acid and ethylene or styrene, is used, and its two surfaces carry charges with a different sign.

As an especially appropriate method for the manufacturing of the electret according to the present invention, there is the method according to which there is an electrical insulation material placed on one side of the film, sheet or molded material formed from the above described copolymer material, and a high energy electron beam is irradiated towards the molded material from the side that is opposite to that electrical insulation material, and an electret is produced where the irradiated surface has a positive charge and the opposite surface has a minus charge.

The goal of the present invention is to suggest an electret, which has on its two surfaces electrical charge with opposite signs, and whose electrical charge amount is large, and also, where the attenuation of the electrical charge is small.

In the past, the so-called thermal electretization, has been studied, where an electrical field is applied to a polymer material under heating, and after that it is cooled as it is kept in the state where the electrical field is being applied, and polyethylene, polypropylene, polyvinyl chloride etc., have also been included in the polymer materials, which have been the subject of these studies. Then, regarding the electretization of the vinyl type polymer materials, the incorporation of carboxylic radicals into the polymer material causes a decrease of the electrical properties and especially of the electrical insulation

properties, and from the point of view of the electretization, it has been possible to consider that as an option, which is not preferred.

However, the authors of the present invention have conducted rigorous research and as a result from that they have observed that if the conditions are appropriately selected, an excellent electret is produced from copolymer materials obtained from acrylic acid, methacrylic acid or maleic acid, or their salts, and from ethylene or styrene. Especially, if the electretization treatment is conducted by using electron beam radiation, it is different from the thermal electretization used according to the previous technology and the electretization is achieved through a radiation treatment, which is and is done within an extremely short period of time. And because of that, the characteristics are present that there is no deformation or destruction of the film, sheet, etc., formed products, and not only that, but also, the amount of the electric charge of the obtained electret is extremely high and its electrical charge attenuation is small, and besides that through the selection of the raw materials, it is also possible to impart electric voltage properties and light guide properties. And because of that, this material is extremely useful as a material for audio equipment, like microphones, pick up, speakers, etc., also, it is appropriate in electron copying applications or printing applications, and then in medial field materials, and especially, as materials used in medical instruments which come in contact with blood, etc.

The electret material used according to the present invention is a copolymer material obtained from acrylic acid, methacrylic acid or maleic acid and from ethylene or styrene, or it is a material where a metal ion has been added to the above described copolymer material. However, it is also a good option if copolymer materials are used, which contain correspondingly two types or more of the above described components. Also, it is a good option if the above described copolymer components are used as the main components, and small amounts of other different components are contained as long as it is within the range where there is no deterioration of the properties. In the copolymer material, the amount of the acrylic acid, methacrylic acid or maleic acid is 25 mole % or less, and especially it is preferred that it is 15 mole % or less. Moreover, the term copolymer that is used here includes random, block and conjugated type polymer materials, and besides that it also includes polymer materials obtained by graft copolymerization.

As the electret material according to the present invention, it is possible to use the above described copolymer material by itself, however, then preferably, the composition material is used, which is formed as a metal ion is added to the above described copolymer material. As the metal ion, which is contained in the above described copolymer material used as the electret material according to the present invention, the metals from the Groups I, II, III, VIII from the Periodic Table, especially, Na+, K+, Ag+, Cu+, Cu++, Ca++, Ba++, Zn++, Fe++, Al+++ etc., are preferred.

The above described copolymer material which contains metal ions such as the above described can be produced according to the following method: usually, to a material obtained by the copolymerization of acrylic acid, methacrylic acid or maleic acid and

ethylene or styrene, or to copolymer material, obtained by the graft polymerization of acrylic acid, methacrylic acid or maleic acid onto ethylene or styrene, sodium hydroxide, calcium hydroxide, barium hydroxide, aluminum hydroxide etc., hydroxides of the above described metals, sodium acetate, calcium acetate, zinc acetate, etc., acetic acid salts of the above described metals, calcium oxide, zinc oxide, etc., oxides of the above described metals, barium stearate, calcium stearate, sodium stearate, zinc stearate, etc., high homologous order aliphatic acid salts of the above described metals, metallic zinc etc., above described metals by themselves, are added and mixed. However, for example, these can also be produced according to the method whereby a styrene – acrylic acid copolymer material is dissolved in toluene, and to that a methanol solution of potassium hydroxide is added, and stirred, and in a state where it is a solution to a state where it is close to solution, the neutralization of the carboxylic radical, is conducted. Also, these can be produced according to the method where the neutralized by the above described metal acrylic acid, methacrylic acid or maleic acid is copolymerized with ethylene or styrene.

Moreover, regarding the addition of the metal ion, it is preferred that the incorporated amount be controlled so that the bulk specific resistance of the electretized formed material becomes $10^{13} \Omega$ cm or higher.

The copolymer material used according to the present invention is made into a film, a sheet or a formed material, which is formed and processed from those, and after that an electretization treatment is conducted, and because of that naturally, a molecular weight is necessary to only resist such forming (molding) processes, and it is necessary to obtain a material, which has the appropriate processing properties, namely melting or dissolution properties, however, there is no problem if after the molding it is rendered insoluble and it is not melted. The molecular weight is preferred to be at least 500 or higher, represented by the average polymerization degree.

According to the above described, for the preparation of the electret according to the present invention, an electretization treatment is appropriately applied onto the above described copolymer material, which has been processed into a film, sheet, or closed tubular shape etc., items. As the film forming method, besides the method whereby a solution or a material, which is an state close to solution, is spread, the melt molding method, especially, the pressure shrinkage molding method, the injection method, the extrusion method, the vacuum molding method, the blowing method, the inflation method, the calendering method, etc., are desirable. It is also possible to add and mix anti-oxidation agents, ultraviolet absorption agents, light stabilization agents, heat stabilization agents, etc., different types of stabilization agents, plasticizers, anti-electrostatic agents, flame retardants, filler agents, lubricants, etc., however, it is preferred that the added amount be controlled so that the electrical resistance of the obtained molded material, namely, the bulk specific resistance becomes $10^{13} \Omega$ cm or lower.

Moreover, the formed material can be non-oriented, uniaxially oriented, biaxially oriented, and all are good options. The thickness of the formed material varies depending

on the electretization method to which it must be subjected, however, for example, in the case when the electretization is conducted by the electron beam radiation treatment, it is desirable that the thickness of the single molded item be 1000 microns or less. And also, even in the case when the molded items are stacked and then treated, it is a good option if the total thickness becomes 5 mm or less. However, if the electron beam radiation conditions are changed and the radiation amount is made to be high, it is also possible to treat materials, which have thickness higher than the above described. In the case when the described below light radiation electretization treatment, thermal electretization treatment are conducted, because of the fact that it is a good option if the applied electrical voltage is constantly normalized relative to the thickness of the molded material, the limit of the thickness of the molded material is determined by the capability of the high electrical voltage generating equipment.

The present invention is an invention about an electret, which has on its two surfaces electrical charge with a different sign, and which is obtained as electron beam radiation, or electrical field, heat, light etc., are applied to a material formed from a copolymer obtained from acrylic acid, methacrylic acid or maleic acid and from ethylene or styrene, and preferably, from the above described copolymer containing a metal ion, and it is electretized. And because of that, here below, the main electretization methods are explained, however, the electretization methods are not limited to these electretization methods.

(i) Electron beam radiation electretization method:

Here the term electron beam has the meaning of an electron beam with energy of 150 key or higher, and as the radiation device used in practice, there are the Cockroft type electron acceleration device, the Cockroft – Fulton type electron acceleration device, the Van de Graf type electron acceleration device, the resonance transformation device, the linear type electron acceleration device, the Betatrone, the Dynamitron type electron acceleration device, the steel core insulation type electron acceleration device, etc. It is also a good option if there is an electric insulation material on one side of the above described copolymer, or preferably the above described copolymer material containing a metal ion, that has been formed into a film shape, a sheet shape, or a closed tubular shape etc. The irradiation is conducted so that the electron beam is direct relative to the material formed from above described copolymer, and this is achieved as the electron beam is irradiated to the formed material from the side opposite to the side of the electric insulation material, and it is a good option if at this time the distance between the formed material that is being electretized and the electric insulation material is made to be 1 cm or less, and it is also preferred that both materials are intimately adhered. Also, as the material that is being referred to here as the electric insulation material, besides polyethylene, polypropylene, polystyrene, poly tetrafluoroethylene, polycarbonate, polymethyl methacrylate etc., different types of organic materials, also, glass, ceramics etc., inorganic materials, and composite materials formed from both types above, are included. The radiation amount varies depending on the thickness of the formed material

that is subjected to the electretization, the radiation beam resistance properties, or the magnitude of the obtained electrical charge, however, it is preferred that it be within the range from 0.01 to 50 Mrad. The radiation time varies depending on the electron acceleration electrical voltage, the electron beam electric current, etc., however, in order to prevent destruction of the formed materials, it is preferred that it be completed as soon as possible and within several seconds. The electron beam radiation can be conducted in air and under normal temperature and pressure, however, it is also possible to be conducted in vacuum or in inert gas atmosphere like nitrogen or argon gas, and also, it is possible to have heating or light from a light source such as a xenone lamp or mercury lamp, during the time of the radiation.

(ii) Thermal electretization method:

It is the thermal electretization method where alumina foil, etc., conductive material, which becomes a surface electrode is placed in contact with both surfaces of the molded material that is to be electretized, and two electrode conductive bodies are shorted, and by that an electrical voltage is applied, and electrical field is applied to the molded material and it is heated. In the state where the molded material has been subjected to an electrical field and it has been heated for a certain amount of time, it is cooled.

Regarding the electrical voltage, which is applied at this time on both electrode conducting bodies, it is limited to a voltage which will not destroy the insulation of the molded material that is being electretized, and it is a good option if it is high as it goes up to that limit, however, it is preferred that it be from 0.1 to 1000 KV, relative to 1 cm thickness of the molded material. Also, naturally, the heating temperature is limited to the point so there is no melt flow of the molded material, and for the copolymer material, which is used to produce the electret according to the present invention, usually, it is preferred that the temperature be 200oC or lower. Regarding the heating time, it is sufficient if it is maintained at the highest heating temperature for a period of 30 minutes.

(iii) Light radiation electretization method:

Depending on the requirements, it is possible that an electrical field is applied in the copolymer material that is used according to the present invention and by that only it is simply electretized. However, in the case of the electrets such as these, a trend has been observed that it could be stated that the electric charge attenuation is relatively fast. Then, it has been observed that the irradiation of light is effective at the time when the electrical field is being applied. Namely, in order to apply electrical field, electrode, conductive bodies are placed on both surfaces of the molded material that is to be electretized, however, on at least one of the surfaces an electrode formed from transparent electro-conductive material, is placed, and the electrical field is applied as light is being radiated.

Regarding the electrical voltage, which is applied at this time on both electrode conducting bodies, it is limited to a voltage which will not destroy the insulation of

the molded material that is being electretized, and it is a good option if it is high as it goes up to that limit, however, it is preferred that it be from 0.1 to 1000 KV, relative to 1 cm thickness of the molded material. As the light source used in this method, there are the mercury or the xenone lamps. In this case, the illumination at the surface of the material and the time of the light radiation, vary depending on the chemical composition and the thickness of the molded material, the magnitude of the electrical charge to be obtained, etc., however, usually, it is desirable that it be from 5000 Luxes to 1000000 Luxes, and from 1 second to 5 minutes. Moreover, it is also a good option if prior to the electretization treatment according to the light radiation electretization method, an ultraviolet beam etc., is irradiated to the molded material, and the static electricity is eliminated.

The authors of the present invention have conducted all the measurements of the electric properties of the electret after the sample materials have been left for 24 hours in a chamber where the temperature was controlled at 20oC and the humidity was controlled at 65 % RH, and the methods described here below were used to conduct the measurements.

(i) Electric resistance:

The electric resistance was measured by using the high voltage power supply TR-300 B, manufactured by Takeda Research, and a co-oscillation capacity type electric potentiometer TR-84B, a co-ultra-high mega ohm meter and a sample chamber TR-4, were used, and by following the regulations according to JIS.

(ii) Surface electric potential:

A rotary static tester manufactured by Koa Shokai was used. This equipment has been produced in order to measure triboelectricity in the past, however, it was used without the installation of the material subject to the friction.

The sign of the electric charge is was determined from its wave shape when an oscilloscope was attached to this device.

(iii) Surface charge density:

The following two methods were used.

Parallel flat plate condenser: The surface charge density is obtained according to the described here below equation, from the surface electric voltage Va (Volts), measured by grounding the back surface of the experimental sample with a copper foil spread over at the experimental sample fixing location of the rotary static tester manufactured by Koa Shokai, and from the separately measured dielectric constant ε_S .

$$V_A \ . \ \epsilon_S$$
 Surface Charge Density: $\rho_S = ---- \ x \ 0.0855 \ x \ 1.0$

(Coul/cm2)

Here, d represents the thickness of the molded material (cm), ε_S represents the value measured by using direct current according to the method that has been reported on pages $144 \sim 147$ of the Volume 4 of "Physical Measurement Technology".

Non-polarizing electric current method: The method reported in the "Fibers and Technology" 2 (9), 649 (1970) by Komatsu is used appropriately as is, and it is a method where in the case where the electret is heated as it is in state where both surfaces of the electret are shorted, the amount of the electric current flowing through the circuit is added and the value, which is divided by the electrode area is tabulated.

From the measurement results the described here below is understood.

Even though there are variations depending on the electretization treatment and conditions, for example, if the electron beam radiation electretization method is used, it is possible to easily produce electret where the surface potential is at least 2000 Volts or higher, the surface charge density is from 10^{-5} to 10^{-7} Coul/cm². Regarding this value, when it is compared to the several values that are known relative to electrets, it is from a unit to several units larger, and this indicates that the obtained by this method electret according to the present invention is an excellent electret. Also, it is an electret where the attenuation of the electric charge is slow, and even after the passage of a period of 3 months, there is almost no change from the initial value of the electric charge amount. Also, even after the immersion in water or an aqueous solution of an electrolyte material, the attenuation of the electric charge was low and this is very important characteristic.

Moreover, it is an electret where there is no significant difference generated in the attenuation of the electric charge between the case when after the electretization treatment the obtained electret is stored at a bright location and the case when it is stored at a dark location. And it is considered that is due to the fact that by the electretization of the copolymer material through the electron beam radiation, it becomes a material possessing photoelectric conductive properties.

As it has already been reported, the electretization method by the so-called thermal electretization method whereby an electric field is applied as a vinyl type polymer material, containing polyethylene, polypropylene etc., poly - α - olefins is being heated, is known. However, there is no known example stating the preparation of a high performance electret obtained from a material such as a vinyl type copolymer material where carboxyl radical, which has been considered to be a material that is not preferred as a material to be incorporated from the point of view stated about the electretization according to the previous technology, or then, carboxyl radical and metal ion, have been incorporated.

Regarding the present invention, it is not only simply an invention about finding an electretization method for the electretization of materials that up to now have been stated to be materials that $\chi ouldet \delta$ not be electretized, such as copolymers obtained from acrylic

acid, methacrylic acid or maleic acid and ethylene or styrene, and about the preparation of a novel electret. But also, for example, if the electron beam radiation electretization method used in the preparation of the electret according to the present invention is appropriately used on high density polyethylene, only electrets with a surface electric potential of 50 Volts or less, are obtained. And as it is clear from the fact that it is possible to obtain a high electric charge possessing electret, which has 2500 Volts from a polyethylene type copolymer material, that contains 7 mole % of acrylic acid, and where by using Zn++ 30 % of its carboxylic radicals, have been neutralized, and from the fact that a low density polyethylene with a bulk specific resistance of $10^{16} \Omega$ cm, cannot be electretized at all according to the electron beam radiation electretization method used for the production of the electret of the present invention, however, the above described copolymer material, which contains carboxylic radical, and more preferably contains carboxylic radicals and metal ions, and which is a material with a bulk specific resistance of $10^{13} \Omega$ cm or higher, is said to be easily electretized, etc., facts, the ideas defined according to the previous technology have been completely destroyed, and the discovery of the additional result of the incorporation of the carboxylic acid radical or the carboxylic acid radical and the metal ion is very important for the technology.

Then, in the case of the electron beam radiation electretization method and the light radiation electretization method used for the preparation of the electret according to the present invention, compared to the used up to now thermal electretization method, not only are the electretization procedures significantly simplified, but also, the achieved electrical charge of the obtained electret becomes significantly increased, and also, especially, an electret is produced where the radiation surface has a positive electric charge and the opposite surface has a negative electric charge, which is important for the electron beam radiation electretization method, and from this point of view, this is an important characteristic of this method. The fact is that the use of the electron beam radiation electretization method for the preparation of electrets which have negative electric charge on both surfaces is already known for poly tetrafluoro ethylene, polyethylene terephthalate, polycarbonate, however, the preparation of the electret where the radiation surface stably holds a positive electric charge and the surface opposite to that stably holds a negative electric charge, which is obtained according to the method used in the present invention, has not been known at all.

Here below, the present invention will be explained by using practical implementation examples.

Practical Example 1

Ionomer – Sarin "# 1557 (ethylene – methacrylic acid copolymer material (20 mole % methacrylic acid) containing 2 % Zn++), manufactured by Du Pont Company, was made into a film with a thickness of 150 microns by using a heat pressing method, and this was spread over a glass plate, and an electron beam was irradiated in an air atmosphere from the side opposite to the glass plate, by using a Van de Graf type electron acceleration device. The acceleration electric voltage was 8 cm/min, and the radiation doze was 5 Mrad. After the radiation, the film was removed, and the obtained electret was left to

stand for 24 hours in a chamber at a temperature of 20oC and a relative humidity of 65 %, and the static electricity effects etc., were removed and after that when the surface electric potential was measured according to the described above methods, the radiated surface was +2500 Volts and the opposite surface was -2500 Volts. The surface charge density calculated according to the parallel flat plate condenser method, was 5.2×10^{-7} Coul/cm², and the surface charge density calculated according to the non-polarizing electrode electric current was 0.9×10^{-6} Coul/cm². Moreover, this electret, even after one month, had electric potential of $+1500 \sim 200$ Volts on the radiated surface and $-13090 \sim -1800$ Volts on the surface opposite to that.

Practical Example 2

Polyethylene copolymer material obtained by the copolymerization of 15 mole % of methyl methacrylate and 5 mole % of methacrylic acid was ion bridged by using sodium hydroxide. The melt index prior to the addition of the sodium hydroxide was 3.6 g/min, and after the addition, it was 0.16 g/min. The obtained by this method polyethylene copolymer material, containing 1.4 weight % of Na+, was made into a film with a thickness of 150 microns by using a heat pressing method, and after that this was uniaxially extruded in air environment at a temperature of 90oC. The orientation ratio was 4 times. This was then spread and adhered over a polyethylene sheet and when it was irradiated by an electron beam of 0.5 Mrad from the side opposite to the polyethylene sheet, an electret was obtained, where the radiated surface carried a positive electric charge and the surface opposite to that carried a negative electric charge. Moreover, electric voltage properties were observed in this electret.

Practical Example 3

Aluminum hydroxide was added to polyethylene copolymer material containing 15 mole % styrene and 5 mole % methacrylic acid, and it was partially made into an aluminum salt, and after that, a film (containing 0.8 weight % Al) with a thickness of 50 microns was produced by using the heat pressing method. To this an ultraviolet light was irradiated for a period of 10 seconds and after that this was placed between nesa glass electrodes, and 1000 Volt electric voltage was applied on both electrodes, and an electric field was applied to the film, and from the side of the plus electrode a light from a xenone lamp was irradiated so that the illumination level at the surface of the experimental material became 120000 Luxes. The time period of the irradiation was 30 seconds. The obtained electret carried an electric charge of +500 Volts on the surface of the side, which was light irradiated, and -460 Volts on the surface of the opposite side.

Practical Example 4

When the same film as that used according to the above Practical Example 3 was used and the radiation by the xenone lamp light source was not conducted, but only an electric field was applied, an electret was obtained, which carried an electric charge of +300 Volts on the surface in contact with the plus electrode, and -420 Volts on the surface of the opposite side, however, after 3 days, there was a decrease to 50 volts or below.

Practical Examples 5 ~ 8

Different types of films were placed on a polymethyl methacrylate plate, and from the top a 5 Mrad electron beam was irradiated and the results shown according to Table 1, were presented.

Table 1

Practical Examples	Radiated Film	Surface Electric Voltage ** (Volts)			
	Material	Type of contained metal ion	Orientation*	Radiated surface	Non-radiated surface
5	Ethylene/vinyl acetate/acrylic acid copolymer (vinyl acetate: 10 mole %, acrylic acid: 20 mole %)	-	NO ·	+860	-790
6	Ethylene/methacrylic acid copolymer (methacrylic acid: 20 mole %)	Na (3.45 weight %)	UO (x 2.0)	+1200	-1100
7	Ethylene/methacrylic acid copolymer (methacrylic acid: 20 mole %)	Zn (4.9 weight %)	BO (x 3.0 x 3.0)	+2850	-2630
8	Styrene/acrylic acid copolymer (acrylic acid: 10 mole %)	Ca (0.55 weight %)	NO	+520	-580

Moreover, in the case of the Practical Examples $5 \sim 8$, the bulk specific resistance of the films was $10^{13}\,\Omega$ cm or higher. In the case of the electret obtained according to the Practical Example 7, when it was stored in a dark box for a period of 1 month, the surface electric potential was 2850 and there was almost no attenuation, however, the one stored in a bright location became 2000 Volts. Then, when light from a xenone lamp was radiated towards the electret obtained according to the Practical Example 7, for a period of 5 minutes, the electric charge became 50 Volts or lower.

Practical Example 9

From a copolymer material that was obtained as zinc acetate was added (3.2 weight %) to a copolymer consisting of 97 mole % ethylene and 3 mole % anhydrous maleic acid, a film with a thickness of 50 microns was produced by using the pressing method. This film was placed between aluminum foils, and an electrical field of 500 V was applied so that there was no shorting, and it was heated to 90oC. This was maintained for 30 minutes at this state and in the state as the electric field was being applied, the film was

cooled down to a room temperature. And when that was done, an electret was obtained where both surfaces carried electrical charge with different signs.

Practical Example 10

The film according to the above Practical Example 1 was not spread over a glass plate and the film and the glass were placed at a distance. When the film and the glass plate were placed at a distance of 15 mm, there electretization was not possible, however, in the case when that distance was made to be 5 mm, and in the case when it was made to be 9 mm, electrets were obtained where the surface of the side irradiated by the electron beam radiation carried a positive electric charge and the surface of the opposite side carried a negative charge.

Practical Example 11

Three pieces of the film obtained according to the Practical Example 6 were stacked and this was then placed on the top of a glass plate and the air in the ambient atmosphere was exchanged with nitrogen, and then to that an electron beam of 0.25 Mrad was irradiated from the side opposite to the glass plate. Electrets were obtained where all of the surfaces of the sides where the electron beam has been projected were positively charged and all the surfaces of the opposite sides were negatively charged.

(57) Scope of the Claims of the Invention

- 1. Electret, which is formed as a film shaped or sheet shaped material, which is formed from copolymer material obtained from acrylic acid, methacrylic acid or maleic acid and ethylene or styrene, is used, and its two surfaces carry charges with a different sign.
- 2. Electret, which is formed as a film shaped or sheet shaped material, which is formed from copolymer material obtained from the metal salt of acrylic acid, methacrylic acid or maleic acid and ethylene or styrene, is used, and its two surfaces carry charges with a different sign.

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発明の詳細な説明

本発明は、エレクトレツトに関するものである。 さらに詳しくは、本発明は、

- とエチレンまたはスチレンとの共重合体から成 るフイルム状又はシート状体で、その両面が異 符号の電荷を有するエレクトレツト、
- (2) アクリル酸、メタクリル酸またはマレイン酸 体から成るフイルム状又シート状体で、その両 面が異符号の電荷を有するエレクトレツト、 に関するものである。

本発明のエレクトレツトの製造するに特に適し た方法は、上記共重合体から作成したフイルム、 30 シートまたは成形物の一側に電気絶縁体をおいて、 電気絶縁体とは反対の側から高エネルギーを有す る電子線を成形体に照射し、照射面が正、反対面 が負の電荷を有するエレクトレットをつくる方法 である。

本発明の目的は、その両面に反対符号の電荷を 有し、その電荷量が大であり、かつ電荷の減衰の 小さいエレクトレツトを提供することである。

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従来、重合体に対して加熱下で電場をかけ、つ いで電場をかけたまま冷却するといういわゆる熱 エレクトレツト化が検討されており、その対象と 5 なる重合体中にはポリエチレン、ポリプロピレン、 ポリ塩化ビニルなども含まれている。 そしてビニ ル系重合体のエレクトレット化については、重合 体にカルポキシル基を導入することは、電気的性 質、とくに電気絶縁性を低下させることになつて 10 エレクトレツト化という観点からは好ましくない ものと考えられてきた。

ところが、本発明者等は鋭意研究の結果、条件 を適当に選べば、アクリル酸、メタクリル酸また はマレイン酸、あるいはこれらの金属塩とエチレ 15 ンまたはステレンとの共重合体からすぐれたエレ クトレツトをつくり得ることを見い出した。とく に電子線照射によるエレクトレツト化処理を行え ば、従来の熱エレクトレット化処理とちがつて、 簡便で、極く短時間の照射処理によつてエレクト (1) アクリル酸、メタクリル酸またはマレイン酸 20 レツト化が達成されるため、フイルム、シートた どの成形品を変形、破損させることなく、しかも 得られたエレクトレツトの電荷量が非常に大きい こと、その電荷の減差の少ないことのほかに、原 材料の選択によっては圧電性や光導電性をも付与 の金属塩とエチレンまたはスチレンとの共重合 25 しうるという特徴があつて、マイクロホン、ビツ クアツブ、スピーカなどの音響機器の材料として、 また電子複写や印刷用の用途に、さらには医療用 材料、とくに血液と接触する医療器具用材料など として極めて有用である。

> 本発明で使用するエレクトレット材料は、アク リル酸、メタクリル酸またはマレイン酸とエチレ ンまたはスチレンとの共重合体、あるいは上記共 重合体に金属イオンを添加したものであるが、上 記成分をそれぞれ二種以上含んだ共重合体を使用 35 してもよい。また、上記共重合成分を主成分とし、 その特性を損なわない程度に共重合等により他の 少量成分を含有させてもよい。共重合体中、アク

リル酸、メタクリル酸またはマレイン酸は25モ ル%以下、好ましくは15モル%以下が望ましい。 なお、ここで共重合体というのは、ランダム、プ ロツク、交互共重合体のほかに、グラフト共重合 させて得た重合体も含まれる。

本発明のエレクトレツトの材料としては上記共 重合体単独でも使用できるが、好ましくはさらに 上記共重合体に金属イオンを添加して成る組成物 が使用される。本発明のエレクトレツトの材料と オンは、周期律奏第Ⅰ,Ⅱ,Ⅲ,滙族に属するも Cutt, Catt, Batt, Zntt, Fett, Altt などが望ましい。

は、一般的にはアクリル酸、メタクリル酸または マレイン酸とエチレンまたはスチレンとを共重合 させて得たもの、あるいはエチレンまたはスチレ ンにアクリル酸、メタクリル酸またはマレイン酸 をグラフト重合させて得た共重合体に、水酸化ナ 20 ことが望ましい。 トリウム、水酸化カルシウム、水酸化パリウム、 水酸化アルミニウムなどのような上記金属の水酸 化物、酢酸ナトリウム、酢酸カリウム、酢酸亜鉛 のような上記金属の酢酸塩、酸化カルシウム、酸 酸パリウム、ステアリン酸カルシウム、ステアリ ン酸ナトリウム、ステアリン酸亜鉛のような上記 金属の高級脂肪酸塩、金属亜鉛のような上記金属 の単体を添加退練する方法でつくられるが、 たと 溶解し、これに水酸化カリウムのメタノール溶液 を添加、攪拌するというように、溶液ないし溶液 に近い状態でカルポキシル基の中和を行なう方法 でもつくられる。また上記金属イオンで中和した アクリル酸、メタクリル酸またはマレイン酸をエ 35 つて決められるわけである。 チレンまたはスチレンと共重合させる方法によつ てもつくることができる。

なお、金属イオンの添加にあたつては、エレク トレット化する成形物の体積固有抵抗が10¹³Ω しいる

本発明に使用する共重合体は、フイルム、シー ト、あるいはそれらから成形加工される成形物に してから、エレクトレット化処理を施すので、そ

うした成形加工に耐えるだけの分子量と、適度の 加工性。すなわち溶解あるいは溶融性を有するこ とが必要なことは当然であるが、成形後には不溶 不融化しても何らさしつかえない。分子量は、平 5 均重合度で少なくとも500以上が望ましい。

前述の通り、本発明のエレクトレツトを得るに はフイルム、シートあるいは封筒状などに成形加 工した上記の共重合体にエレクトレツト化処理が 適用される。成形成膜方法としては、溶液あるい して使用する上記共重合体に含有させうる金属イ 10 は溶液に近い状態として流延させる方法のほかに、 溶融成形法、とくに圧縮成形法、射出成形法、押 出し成形法、真空成形法、吹込成形法、インフレ ーション法、カレンダー法などが望ましい。成形 の過程あるいは成形に先立つて、酸化防止剤、紫 このような金属イオンを含有する上記共重合体 15 外線吸収剤、光・熱安定剤など各種安定剤、可塑 剤、帯電防止剤、難燃剤、充てん剤、滑り剤など を添加混合することができるが、 得られる成形物 の電気抵抗すなわち体積固有抵抗が10¹³ Ωcm 以下とならないように添加剤の添加量を調節する

なお、成形物は無延伸、一軸延伸、二軸延伸の いずれであつてもよい。成形物の厚みは、これに 施すべきエレクトレット化の方法に従つて異なる . が、たとえば電子線照射処理によつてエレクトレ 化亜鉛のような、上記金属の酸化物、ステアリン 25 ツト化させる場合には、成形物一枚当りの厚みは 1000 µ以下にすることが望ましく、また成形 物を重ねあわせて処理する場合にも厚み合計が5 **以下になるようにするのがよい。ただし、電子線 **照射条件をかえて照射量を大きくすればこれ以上** えばスチレンーアクリル酸共重合体をトルエンに 30 の厚みを有するものとすることもできる。後述の 光照射エレクトレツト化処理、熱エレクトレツト 化処理における場合も、成形物の厚さ当りの印加 電圧を一定規準以上にすればよいわけであるから、 成形物の厚さの限界は高電圧発生装置の能力によ

本発明は、アクリル酸、メタクリル酸またはマ レイン酸とエチレンまたはスチレンの共重合体。 好ましくは金属イオン含有の上配共重合体の成形 物に電子線照射や電場、熱、光などを加えること cm以上になるように導入量を調節することが望ま 40 によつてエレクトレット化して得られ、両面が異 符号の電荷を有するエレクトレツトに関するもの であるから、次に主なるエレクトレツト化方法を 説明するが、エレクトレツト化の方法はこれらの 方法だけに限定されるわけではない。

(j) 電子線照射エレクトレツト化法:

ここで電子線というのは150 kev 以上のエ ネルギーを有する電子線を意味し、実際に使用し うる照射装置としては、コツククロフト型電子加 速器、コツククロフト・ワルトン型電子加速器、 5 に 2 0 0 ℃以下が望ましい。加熱時間は、最高加 パン・デ・グラフ型電子加速器、共振変圧器、線 型電子加速器、ペータトロン、ダイナミトロン型 電子加速器、鉄芯絶縁型電子加速器などがある。 ---フィルム状、シート状あるいは封筒状などに成形 加工した上記の共重合体、好ましくは金属イオン 10 るだけで簡単にエレクトレツト化されるものがあ 含有の上記共重合体の一側に電気絶縁体をあてが い、電子線が直接上配の共重合体の成形物に当た るように、電気絶縁体の側とは反対の側から成形 物に電子線を照射するわけであるが、この際エレ クトレット化しようとする成形物と電気絶縁体と 15 をかけるためにはエレクトレット化しようとする の距離は1cm以下にするのがよく、両者を密着さ せるのが最も好ましい。また、ここでいう電気絶「 緑体の材料としては、ポリエチレン、ポリプロピ レン、ポリスチレン、ポリ4フツ化エチレン、ポ リカーポネート、ポリメチルメタクリレートなど 20 各種の有機物質以外に、ガラス、セラミツクなど の無機材料、および両者の複合材料も含まれる。 照射量は、エレクトレツト化しようとする成形物 の厚み、耐放射線性、あるいは得ようとする電荷 50 Mrad の範囲が望ましい。 照射時間は、電 子加速電圧、電子ピーム電流などによつても異な るが、成形物を破損しないためにはせいせい数秒 程度にとどめることが好ましい。

るが、真空中、あるいは窒素やアルゴンのような 不活性ガス中でも行なうことができ、また照射時 に加熱したり、あるいはキセノン灯や水銀灯のよ うな光源からの光を同時照射することもできる。

(II) 熱エレクトレツト化法: ¨

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エレクトレツト化しようとする成形物の両面に アルミ箔のような面電極となる導体を接触させ、 二つの電極導体が短絡しないようにして、これに 電圧を印加して。成形物に電場をかけて加熱する。 一定時間加熱したら電場をかけたまま成形物を冷 40 8 4 B、同ウルトラ・ハイ・メグオームメータ及 却するというのが熱エレクトレツト化法である。

この際両電極導体に印加する電圧は、エレクト レツト化しようとする成形物の絶縁破壊を生じな い限り、どれほど高くてもよいが、成形物の厚さ

1㎝当り0.1ないし1000KV が好ましい。ま た加熱温度は成形物が溶融流動しない範囲にとど めるべきことは当然であり、本発明のエレクトレ ツトを作るに使用する共重合体については一般的 熱温度に30分間保持すれば十分である。

(jii) 光照射エレクトレツト化法:

意くべきことに、本発明のエレクトレツトを作 るのに使用しうる共重合体の中には、電場をかけ るが、このようにして得られたエレクトレツトは 電荷の減衰が比較的速いという傾向がみとめられ る。そこで電場をかける際に、光を照射するのが 効果的であることを見い出した。すなわち、電場 成形物の両面に電極導体を接触させるわけである が、少なくとも一面だけはネサガラスのような透 明導電性材料から成る電極を配置して、光を照射 しながら電場をかけるのである。

この際両電極は印加する電圧は、成形物試料の 絶縁破壊を生じない限りどれほど高くてもよいわ けであるが、成形物の厚さ1㎝当り0.1ないし 1000KV の範囲が望ましい。この方法に使用 しうる光源としては、水銀灯やキセノン灯などが 量の大きさなどによつて異なるが、 0.0 1 ないし 25 ある。この場合、試料表面における照度および光 照射時間は、成形物の化学組成や厚み、得ようと する電荷量の大きさなどによつても異なるが、普 通は0.5万ないし100万ルツクス、1秒ないし 5分程度が望ましい。なお、光照射エレクトレツ 電子線照射は、空気中、常温常圧下でも行なえ 30 ト法によるエレクトレット化処理に先立つて成形 物に赤外線などを照射して、静電気を除去してお くのもよい。

> 本発明者等は、エレクトレットの電気的性質の 測定は、すべて20℃、65%RHの温調室内に . 35 2 4時間以上放置した試料について、次の方法を 用いて行なつた。

(i) **電気抵抗:**

タケダ理研製ハイ・ポルテージ・パワー・サブ ライTRー300B、同振動容量型電位計TRー びサンブル・チャンパーTR-42を用いて、 JIS規格に準じて測定した。

(11) 表面電位:

興亜商会製ロータリ・スタチツク・テスタを用

いた。この装置は本来摩擦静電気を測定するため ※ 次の2通りの方法を用いた。 に作られたものであるが、摩擦対象物を取りつけ ないで使用した。

電荷の符号は、この装置にシンクロスコープを 取りつけてその波形から判定した。

(削) 表面電荷密度:

平行平板コンデンサ法:興亜商会製ロータリ・ スタチック・テスタの試料固定個所に網箔を張り つけて試料の裏面が接地されるようにして測定し 5 た表面電位 $\mathbf{V}_{\mathbf{A}}$ (ポルト)と、別に測定した誘電 * 率 s g から次式によつて算出した。

 $\times 0.0.855 \times 1.0$

(Coul/cm²)

The second second second

ここでdは成形物の厚み(cm)であり、eg は 「物理測定技術」第4巻(朝倉書店)第144~ 147頁に記載されている方法で、直流を用いて 求めた値である。

た状態で、エレクトレツトを加熱していく場合に 回路に流れる電流量を積算して、電極の面積で割 つた値をもつて表わす方法で、高松著「繊維と工 業」2(9) 649(1970)記載の方法をその まま適用した。

- 測定の結果から下記のようなことが解つた。

エレクトレツト化の処理や条件によつて違うが、 たとえば電子線照射エレクトレツト化法を用いる と、表面電位2000ポルト以上、表面電荷密度 10⁻⁵ ないし 10⁻⁷ Coul/cm² というよう 25 位 50 ポルト以下のエレクトレツトしか得られな たエレクトレツトも容易に作成することができる。 こうした値はこれまでに、エレクトレツトについ て知られている数値に比べて一桁ないし数桁大き いものでこの方法で得られる本発明のエレクトレ ツトがいかに優れたものであるかを示すものであ 30 や、体積固有抵抗が10¹⁶ Qcmの低密度ポリエ る。また電荷の減衰も遅く、3カ月経過時におい てもほとんど初期電荷量と変化していないものも ある。また水中電解質水溶液に浸漬したあとも、 電荷の減衰が少ないことも大きな特徴である。

エレクトレツトを明るい所に保存した場合と、暗 い所に保存した場合とで電荷の減衰に著しい差異 を生するものがあるが、これは電子線照射による エレクトレツト化によって共重合体が光電導性を もつようになつたためと考えられる。

すでに述べたように、ポリエチレン、ポリプロ ピレンのようなポリーαーオレフインを含むビニ ル系重合体を加熱したがら電場をかけるいわゆる 熱エレクトレット化法でエレクトレット化するこ

とは知られているが、従来エレクトレツト化とい う観点からは好ましくない導入物質であると思わ れてきたカルポキシル基、あるいはさらにカルボ キシル基と金属イオンとを導入したピニル系共重 脱分極電流法:エレクトレツトの両面を短絡し 15 合体のようなものから高性能のエレクトレツトを つくつたという例は知られていない。

本発明は単に、このようなアクリル酸、メタク リル酸またはマレイン酸とエテレンまたはスチレ ンとの共重合体というこれまでにエレクトレツト 20 化が行なわれていない物質のエレクトレット化法 を見い出して新規なエレク トレツトを作つたとい うだけでなく、たとえば本発明のエレクトレツト を作るに用いられている電子線照射エレクトレツ ト化法を高密度ポリエチレンに適用すると表面電 いのに、アクリル酸を7モル%含有し、Zn卄で そのカルポキシル基の30%を中和したポリエチ レン系共重合体からは2500ポルトという高電 荷量を有するエレクトレツトができるという事実 チレンは、本発明エレクトレットを作るに用いら れる電子線照射エレクトレツト化法によつて全く エレクトレツト化されないのにカルポキシル基よ り好ましくはカルポキシル基と金属イオンとを含 たお、エレクトレット化処理の後に、得られた 35 有する前記の共重合体は体積固有抵抗 $10^{13}\Omega$ cm 以上のものが容易にエレクトレツト化されるとい う事実などからもわかるように、従来の固定概念 を全く打ち破る、カルポキシル基、あるいはカル ポキシル基と金属イオンとの導入添加効果を見い 40 出したところに大きな意義がある。

> さらに本発明のエレクトレツトを作るに用いら れる電子線照射エレクトレツト化法や光照射エレ クトレツト化法は、これまでの熱エレクトレツト 化法に比べて、エレクトレツト化操作を大幅に簡

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略化させるだけでなく、得られたエレクトレツト の到達電荷量を著しく高めたことになり、またと くに電子線照射エレクトレツト化法について重要 なことは、照射面が正の電荷をもち、反対面が負 の電荷をもつたエレクトレツトを作成し得ること 5 こうして得たNa+1.4 重量%含有ポリェチレン であつて、この点にこの方法の大きな特徴がある。 なぜなら電子線照射エレクトレツト化法によつて 両面が負の電荷をもつエレクトレツトの作成はす でにポリ 4 フツ化エチレン、ポリエチレンテレフ タレート、ポリカーポネートについて知られてい 10 反対側から 0.5 Mradの電子線を照射したとこ るが、本発明において使用される方法で得られる ような照射面が正、反対面が負の電荷を安定に保 持するようなエレクトレツトの作成は全く知られ ていないからである。

以下、本発明の実施例について説明する。 実施例 1

Du Pont社製アイオノマー・サーリン® 井1557(エチレンーメタクリル酸共重合体 (メタクリル酸20モル%)2n 廿2%含有)を 熱プレス法で厚さ150μのフイルムにし、これ 20 照射してから、両面からネサガラス電極ではさみ、 をガラス板に張りつけて空気中でパンデグラフ型 電子加速器を用いてガラス板とは反対の側から電 子線を照射した。加速電圧は1 Me V、ビーム電 流は100 µA 、ベルト走行速度は8㎝/min で、照射量は5Mradであつた。照射後フイル 25 られたエレクトレツトは、光が照射された側の面 ムをはがし、得られたエレクトレツトを20℃、 65%RHの温調室に24時間放置して静電気な どの影響を除去してから、前に記載した方法で表 面電位を測定したところ照射面が十2500ポル ト、反対面が一2300ポルトであつた。平行平 30 灯光源で照射をしないでただ電場のみをかけたと 板コンデンサ法に従つて計算した表面電荷密度は 5.2×10⁻⁷ Coul/cm²で、脱分極電流で 求めた表面電荷密度 0.9×10⁻⁶ Coul/cm² であつた。このエレクトレツトは1カ月後もなお 照射面が十1500~2000ポルト、反対傾面 35 実施例 5~8 が一1300~1800ポルトの電位を有してい

実施例 2

メタクリル酸メチル15モル%及びメタクリル

酸5モル%と共重合したポリエチレン共重合体を 水酸化ナトリウムによつてイオン架橋した。メル トインデツクスは水酸化ナトリウム添加前が3.6 g/min、添加後が0.16g/min であつた。 共重合体を熱プレスで厚さ150μのフィルムに してから、これを90℃の空気浴中で一軸延伸し た。延伸倍率は4倍であつた。これをポリエチレ ンのシートに張りつけてポリエチレンシートとは ... ろ、照射面が正、反対面が負の電荷をもつエレク トレツトが得られた。たおこのエレクトレツトに は、圧電性がみとめられた。

· 実施例 3

15 スチレシ15モル%、メタクリル酸5モル%を 含むポリエチレン共重合体に水酸化アルミニウム を加え、部分的にアルミニウム塩とした後、熱ブ レス法によつて厚さ50 Aのフイルム(Al0.8重 量%含有)を作成した。これに赤外線を10秒間 両電極に1000ポルトの電圧を印加してフイル ムに電場をかけ、ブラス電極側からキセノン灯の 光を照射し試料表面での照度が12万ルツクスに なるようにした。照射時間は30秒であつた。得 が十500ポルト、反対側の面が一460ポルト の電荷をもつていた。

実施例. 4

実施例3に用いたと同様なフイルムをキセノン とろ、プラス電極に接した面が十300ポルト、 反対面が一420ポルトの電荷をもつエレクトレ ツトが得られたが、3日後には50ポルト以下に 滅衰した。

種々のフイルムをポリメチルメタクリレート板 上に置いて、上方から5Mradの電子線を照射 し表1の結果を得た。

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実施例	無ります。	無射フイルム		表面電位 ※・※(ポルト)	
	材質	含有金属の種類	延伸業	照射面	非照射面
5	エチレン/酢ピ/ アクリル酸共合体	_	ИО	+860	-790
	{酢ピ:10モル%; {アクリル酸:20モル%}			٠	
6	エチレン/メタクリル酸 共重合体 (メタクリル酸:20モル%)	Na (3.45重量%)	UO (×2.0)	+1200	-1100
7	エチレン/メタクリル酸 共 重合体 (メタクリル酸:20モル%)	Zn (4.9重量%)	BO (×3.0×3.0)	+2850	-2630
8	スチレン/アクリル酸 共重合体 (アクリル酸:10モル%)	Ca (0.55重量%)	NO	+520	-580
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- * NOは無延伸、UOは一軸延伸、BOは二軸延伸を、またカツコ . 内はたて及びよこの延伸倍率を表わす。
- ※※ 電子線照射によるエレクトレツト化処理後2日目のエレクトレツ トの表面電位を表わす。

なお実施例5~8は、フイルムの体積固有抵抗 が10¹³ Ωc=以上であった。実施例7のエレク トレツトを、暗箱中で1カ月間保存したところ表 面電位は2850ポルトとほとんど減衰していな かつたが、明るい所で保存したものは2000ポ 30 9 至とした場合には、電子線照射で照射した側の ルトになつていた。さらに実施例7のエレクトレ ツトにキセノン灯の光を5分間照射したところ電 荷は50ポルト以下になつた。

実施例 9

エチレン97モル%、無水マレイン酸3モル% 35 ス板上に置き雰囲気を窒素置換してこれにガラス から成る共重合体に、酢酸亜鉛を添加して(3.2) 重量%)できた共重合体からプレス法で厚さ50 μのフイルムを作成した。このフイルムをアルミ 箔の間にはさみ、短絡しないようにして500V の電場をかけ、90℃まで加熱した。30分間そ40 回特許請求の範囲 の状態に保ち、電場をかけたままでフイルムを室 温まで冷却したところ、フイルム両面が異符号の 電荷を有するエレクトレツトが得られた。 実施例 10

実施例1においてフイルムをガラス板に張付け ないで、フイルムとガラス板とを離して配置した。 フイルムとガラス板との距離を15mmとするとエ レクトレツト化できなかつたが、5季とした場合、 面が正、反対側の面が負の電荷をもつエレクトレ ツトが得られた。

実施例 11

実施例6で用いたフイルムを3枚重ねて、ガラ 板とは反対の側から0.25Mradの電子線を照 射した。電子線が投射されてきた側の面がいずれ も正反対側の面がいずれも負に帯電したエレクト レツトが得られた。

1 アクリル酸、メタクリル酸またはマレイン酸 とエチレンまたはスチレンとの共重合体から成る フイルム状又はシート状体で、その両面が異符号 の電荷を有するエレクトレツト。

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2 アクリル酸、メタクリル酸またはマレイン酸 優引用文献 の金属塩とエチレンまたはスチレンとの共重合体 特 公 昭40-7394 から成るフイルム状又はシート状体で、その両面 が異符号の電荷を有するエレクトレット。

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